

Leti is pleased to invite you to its MEMS Workshop, a technical program presented in conjunction with the 2019 Transducers/Eurosensors Conference, to be held on Tuesday, June 25, 2019 starting at 6:30 pm, Estrel Congress Center, Room 4 (upstairs), Berlin.

Discover the provisional program:



Leti, Your partner for MEMS R&D Jean Philippe Polizzi MEMS Program Manager, Leti



Nanoresonator-based analytical techniques for virus and nanoparticle characterization
Sébastien Hentz
Research director, Leti



Haptic interfaces based on piezo thin films
Gwenael Le Rhun
Piezoelectric material expert Leti



A breakthrough MEMS
microphone concept
Loïc Joet
MEMS senior designer, Leti



MEMS Ultrasonic Transducers: technologies and applications Bruno Fain Project Manager, MUT expert, Leti



Flex your MEMS: Integrating silicon devices into flexible electronics
Philippe Robert
Head of Microsystems & Packaging Section, Leti

The workshop will be followed by a cocktail reception.

Registration is open, free, and available to all event attendees, and others. However, as seating is limited and there are several participants pre-registered, registration is by invitation only and early registration is recommended.

Register for this event at:

https://letimemsworkshopberlin.eventbrite.fr

For more information, please contact: jean-philippe.polizzi@cea.fr







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